



08-29-05

PATENT
790001-2042

FW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : NAKAMURA et al.
Serial No. : 10/752,642
Filing Date : January 7, 2004
For : **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING
THE SAME**
Examiner : Jesse A. Fenty
Art Unit : 2815

745 Fifth Avenue
New York, NY 10151

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Date of Deposit: August 26, 2005

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" Service under 37 CFR 1.10 on the date indicated above and is addressed to: **Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

Adam Ahmed

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1752642

(Signature of person mailing paper or fee)

**AMENDMENT UNDER 37 C.F.R. § 1.111
AND REQUEST FOR INTERVIEW**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the **May 26, 2005** Office Action, setting a three month term for reply.